



B-4227 618899-5/MSG/RP

PATENT

3742

#6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the U.S. Patent Application of:)

CERTIFICATE OF MAILING

Inventor(s): **Hyoung June KIM**)

July 29, 2003

Date of Deposit

Serial No.: **09/886,940**)

Filed: **June 21, 2001**)

Examiner: **Quang T. Van**)

Art Unit: **3742**)

For: **METHODS & APPARATUSES
FOR HEAT TREATMENT OF
SEMICONDUCTOR FILMS UPON
THERMALLY SUSCEPTIBLE
NON-CONDUCTING
SUBSTRATES**)

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RESPONSE TO RESTRICTION REQUIREMENT

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TECHNOLOGY CENTER

In response to the Office Action mailed on May 29, 2003, a response to which is due no later than **September 29, 2003**, Applicants submit the present Election, together with a petition for a one month extension of time pursuant to 37 C.F.R. 1.136(a) and a check in the amount of \$55.00 for the fee set forth in 37 C.F.R. 1.17(a)(1). Please consider the arguments and remarks set forth below, all of which are made without prejudice.

Remarks/Arguments begin on page 2 of this paper.